

190

Accession number:20123715419713

Title:Indirectly pumped 3.7 THz InGaAs/InAlAs quantum-cascade lasers grown by metal-organic vapor-phase epitaxy

Authors:Fujita, Kazuue (1); Yamanishi, Masamichi (1); Furuta, Shinichi (1); Tanaka, Kazunori (1); Edamura, Tadataka (1); Kubis, Tillmann (2); Klimeck, Gerhard (2)

Author affiliation:(1) Central Research Laboratories, Hamamatsu Photonics K.K. Hamakitaku, Hamamatsu, 434-8601, Japan; (2) Network for Computational Nanotechnology, Birck Nanotechnology Center, Purdue University, W. Lafayette, IN 47907, United States

Corresponding author:Fujita, K.

Source title:Optics Express

Abbreviated source title:Opt. Express

Volume:20

Issue:18

Issue date:August 27, 2012

Publication year:2012

Pages:20647-20658

Language:English

E-ISSN:10944087

Document type:Journal article (JA)

Publisher:Optical Society of America, 2010 Massachusetts Avenue NW, Washington, DC 20036-1023, United States

Abstract:Device-performances of 3.7 THz indirect-pumping quantum-cascade lasers are demonstrated in an InGaAs/InAlAs material system grown by metal-organic vapor-phase epitaxy. The lasers show a low threshold-current-density of $\sim 420 \text{ A/cm}^2$ and a peak output power of $\sim 8 \text{ mW}$ at 7 K, no sign of parasitic currents with recourse to well-designed coupled-well injectors in the indirect pump scheme, and a maximum operating temperature of $T_{\text{infmax}} \sim 100 \text{ K}$. The observed roll-over of output intensities in current ranges below maximum currents and limitation of T_{infmax} are discussed with a model for electron-gas heating in injectors. Possible ways toward elevation of T_{infmax} are suggested. © 2012 Optical Society of America.

Number of references:25

Main heading:Metallorganic vapor phase epitaxy

Controlled terms:Epitaxial growth - Jet pumps - Pumping (laser) - Quantum cascade lasers - Vapors

Uncontrolled terms:Current range - InGaAs/InAlAs - Material systems - Operating temperature - Output intensity - Parasitic current - Peak output power

Classification code:618.2 Pumps - 744.1 Lasers, General - 804 Chemical Products Generally - 933.1.2 Crystal Growth

DOI:10.1364/OE.20.020647

Database:Compendex

Compilation and indexing terms, Copyright 2012 Elsevier Inc.